Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	CHANGE OF NAME

CONVEYING PARTY DATA

Name	Execution Date
Molecular Imaging Corp	01/04/2006

RECEIVING PARTY DATA

Name:	Agilent Technologies, Inc.
Street Address:	815 SW 14th Street
Internal Address:	Attn: Sue Hebert DM 525
City:	Loveland
State/Country:	COLORADO
Postal Code:	80537

Name:	Molecular Imaging Corp, a wholly owned subsidiary of Agilent Technologies, Inc.
Street Address:	815 S. W. 14th Street
Internal Address:	Intellectual Property Administration, DM286 Post J5
City:	Loveland
State/Country:	ОНЮ
Postal Code:	80537-0599

PROPERTY NUMBERS Total: 33

Property Type	Number
Patent Number:	5440920
Patent Number:	5587523
Patent Number:	5763767
Patent Number:	5155361
Patent Number:	RE35317
Patent Number:	5750989
Patent Number:	5495109
Patent Number:	5621210

PATENT "
REEL: 017519 FRAME: 0904

500097652

l ₁	ր
Patent Number:	5760396
Patent Number:	5805448
Patent Number:	5630932
Patent Number:	6017590
Patent Number:	5515719
Patent Number:	5612491
Patent Number:	5513518
Patent Number:	5866805
Patent Number:	5753814
Patent Number:	5983712
Patent Number:	6134955
Patent Number:	5654546
Patent Number:	5821545
Patent Number:	4868396
Patent Number:	5500535
Patent Number:	6121611
Patent Number:	6051825
Patent Number:	6245204
Patent Number:	6734438
Patent Number:	6748795
Patent Number:	6952952
Application Number:	11152827
Application Number:	10725769
Application Number:	60650285
Patent Number:	5675154

CORRESPONDENCE DATA

Fax Number: (970)635-6836

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 970 679-3185

Email: Sue_hebert@agilent.com

Correspondent Name: Agilent Technologies, Inc.

Address Line 1: 815 SW 14th Street

Address Line 2: Attn: Sue Hebert DM 525

Address Line 4: Loveland, COLORADO 80537

NAME OF SUBMITTER: Sue A. Hebert



ASSIGNMENT

WHEREAS, the Parties have entered into an Agreement and Plan of Merger effective as of November 29, 2005 under which MI became a wholly-owned subsidiary of Agilent (the "Merger Agreement");

WHEREAS, Agilent has decided to cause the transfer the assets of its wholly-owned subsidiary, MI to Agilent and then to liquidate the MI shell corporation.

NOW, THEREFORE, for and in consideration of the mutual covenants contained in the Merger Agreement, the share purchase price paid by Agilent under the Merger Agreement and for other good and valuable consideration receipt of which each party hereby acknowledges, the parties hereby agree as follows

- 1. GRANT OF RIGHTS. MI agrees to assign all of MI's right, title and interest in its inventions, including without limitation, inventions not yet the subject of patents or patent applications, the patents and the patent applications listed in Exhibit A, including, without limitation, domestic and foreign rights thereto, the right to file domestic and foreign patent applications thereon, and its rights in any and all patents that issue therefrom.
- 2. AMENDMENT. This Agreement shall not be amended or otherwise modified except by a written agreement dated subsequent to the date of this Agreement and signed on behalf of MI and Agilent by their respective duly authorized representatives.
- 3. GOVERNING LAW. This Agreement shall be governed by and construed in accordance with the laws of the State of California.
- 4. ASSIGNMENT. This Agreement shall be binding upon and inure to the benefit of the parties hereto and their respective successors and assigns.

IN WITNESS WHEREOF, the parties have executed this Agreement as of the Effective Date.

Molecular Imaging Corp.

Agilent Technologies, Inc.

its authorized representative

its authorized representative

EXHIBIT A

Country	Title	Pat. or App.	Status
US	Novel stationary- sample stage atomic force microscope with beam-tracking lens and s-shaped scanner	No. 5,440,920	Remarks Issued
US	Atomic force microscope employing beam-	5,587,523	Issued Continuation of 5,440,920
US	Atomic force microscope employing beam-	5,763,767	Issued Continuation of 5,587,523
US	Potentiostatic preparation of molecular adsorbates for scanning probe microscopy	5,155,361	Issued
US	Potentiostatic preparation of molecular adsorbates for scanning probe microscopy	RE 35,317	Issued Reissue of 5,155,361
US	Scanning probe microscope for use in fluids	5,750,989	Issued
US	Electrochemical identification of molecules in a scanning probe microscope	5,495,109	Issued CIP of 5,750,989
US	Microscope for force and tunneling microscopy in liquids	5,621,210	Issued CIP of 5,750,989
US	Scanning probe microscope	5,675,154	Issued CIP of 5,750,989

TTO	1,	F 550 005	T - 1
US	Scanning probe	5,760,396	Issued
	microscope for use in	,	Divisional of
	fluids		5,675,154
US ·	Hybrid control	5,805,448	Issued
	system for scanning		FWC of
	probe microscope		08/403,229
US	Tip etching system	5,630,932	Issued
	and method for	,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	
	etching platinum-		
	containing wire		
	Containing wife		
US	Tips and substrates	6,017,590	Issued
	for scanning probe	0,017,550	Divisional of
	microscopy		
US	Controlled force	5 515 710	5,630,932 Issued
03		5,515,719	1920CC
	microscope for		
	operation in liquids		
US	Formation of a	5,612,491	Issued
03		3,012,491	1
	magnetic film on an		Divisional of
•	atomic force		5,513,518
772	microscope cantilever		
US	Modulation of force	5,513,518	Issued
	sensor for ac		CIP of
	detection in an atomic		5,515,719
	force microscope		
US	Cantilevers for	5,866,805	Issued
	magnetically driven		CIP of
•	atomic force		5,612491
	microscope	:	
US	Magnetically-	5,753,814	Issued
	oscillated probe		CIP of
·	microscope for		5,866,805
	operation in liquids		
US	Magnetic modulation	5,983,712	Issued
	of force sensor for ac	,	CIP of
	detection in an atomic		5,866,805
,	force microscope		-,,
US	Magnetic modulation	6,134,955	Issued
	of force sensor for ac	3,20 1,500	CIP of
	detection in an atomic		5,866,805
•	force microscope		J,000,00J
US	Variable temperature	5,654,546	Issued
03	•), 034,340	1220CA
	scanning probe		:
	microscope based on		
	a peltier device		

		· · · · · · · · · · · · · · · · · · ·	
US	Heated stage for a scanning probe microscope	5,821,545	Issued CIP of
US	Cell and substrate for electrochemical STM studies	4,868,396	5,654,546 Issued
US	Stress cell for a scanning probe microscope	5,500,535	Issued
US	Force sensing probe for scanning probe microscopy	6,121,611	Issued
US	Conducting scanning probe microscope with environmental control	6,051,825	Issued
US	Vibrating tip conducting probe microscope	6,245,204	Issued
US	Scanning probe microscope and solenoid driven cantilever assembly	6,734,438	Issued
US	Pendulum scanner for scanning probe microscope	6,748,795	Issued
US	Topography and recognition imaging atomic force microscope and method of operation	6,952,952	Issued
US	Topography and recognition imaging atomic force microscope and method of operation	U.S. Ser. No. 11/152,827	Pending

US	Fast scanning stage for a scanning probe microscope	U.S. Ser. No. 10/725,769 (Publication No. 2004- 0129873)	Published
US	Cross-linking compositions for use in atomic force microscopy	Provisional U.S. Ser. No. 60/650,285	Pending
JP .	Scanning probe microscope for use in fluids	ЈР3249130	Issued
JP	Magnetic modulation of force sensor for ac detection in an atomic force microscope	JP3249132	Issued
JР	Force sensing probe for scanning probe microscopy	JP2000- 549903	Published
JP	Microscope for compliance measurement	JP2000- 505482	Published
JР	Fast scanning stage for a scanning probe microscope	JP2005- 509973	Pending
GB	Microscope for compliance measurement	EP1002216	Issued
GB	Magnetic modulation of force sensor for ac detection in an atomic force microscope	EP0813675	Issued
GB	Force sensing cantilever for atomic force microscope	EP1080340	Issued
GB	Fast scanning stage for a scanning probe microscope	GB2415042	Published
GB	Topography and recognition imaging atomic force microscope and method of operation	GB2414547	Pending
Germany	Microscope for compliance measurement	EP1002216	Issued

Germany	Magnetic modulation	EP0813675	Issued
	of force sensor for ac		
	detection in an atomic		
	force microscope		
Germany	Force sensing probe	EP1080340	Issued
	for scanning probe		
	microscopy		
Germany	Topography and	DE10393612	Published
	recognition imaging		
	atomic force		
	microscope and		
	method of operation	DE1000000	
Germany	Fast scanning stage	DE10393939	Pending
	for a scanning probe microscope		
France	Force sensing probe	EP1080340	Issued
Tance	for scanning probe	EF1000340	122000
	microscopy		
WO	Fast scanning stage	WO2004-	Entered
	for a scanning probe	059243	
	microscope		
WO	Topography and	WO2004-	Entered
	recognition imaging	042741	
	atomic force		
	microscope and		
	method of operation		

PATENT

RECORDED: 04/25/2006 REEL: 017519 FRAME: 0912